



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

NAKANO, et al

Serial No.:

10/075,244

Filed:

February 15, 2002

For:

METHOD AND APPARATUS FOR PLASMA PROCESSING

Group:

1762

Examiner:

M. Padgett

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 5, 2004

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the second month subsequent to the shortened statutory period set in the outstanding Office Action mailed November 5, 2003. A payment in the amount of \$420.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (501.41175X00).

Respectfully submitted,

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420.00 OP

Melvin Kraus

Registration No. 22,466

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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